

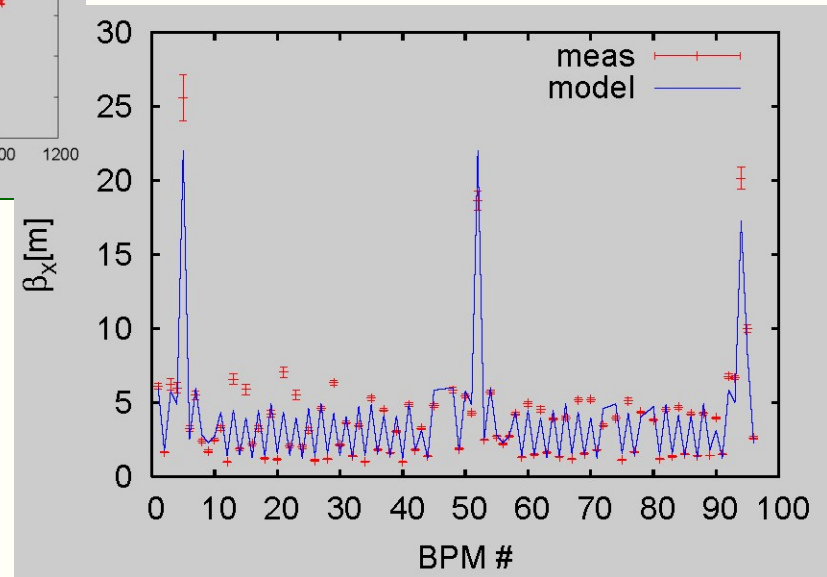
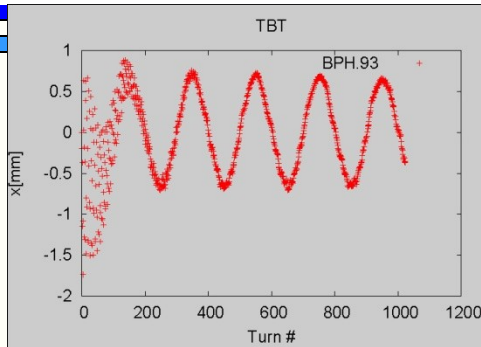
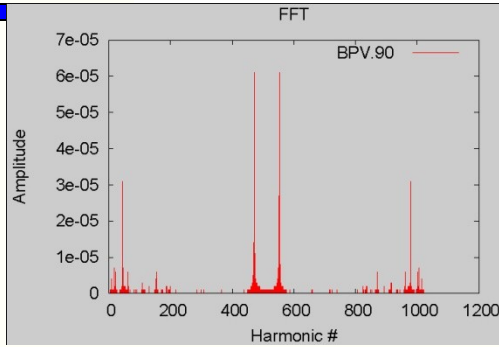
KEK-ATF – Fermilab Collaboration Ideas

**David Johnson, Alex H. Lumpkin,
Vic Scarpine, Manfred Wendt, Fermilab**

Presented at SLAC

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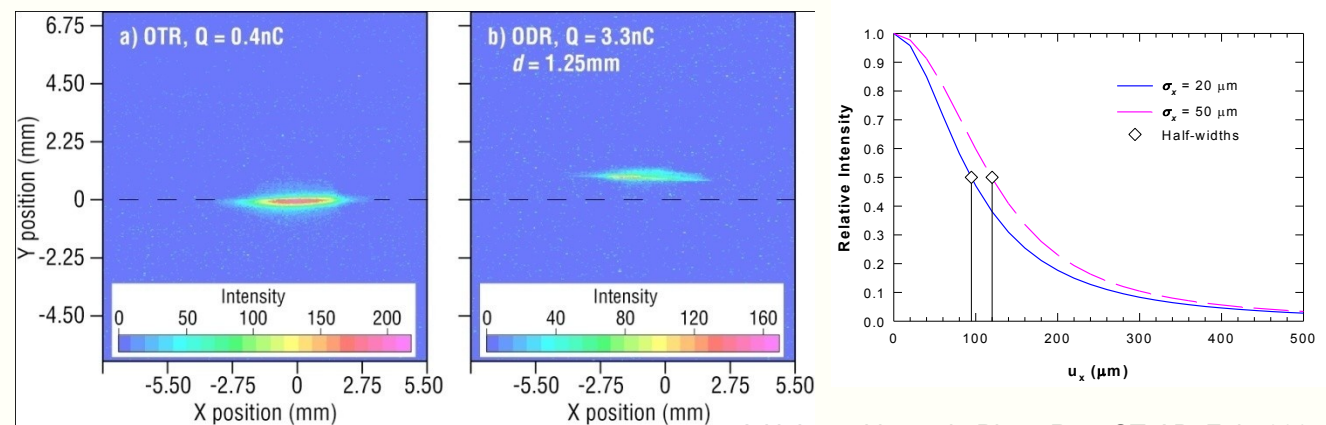
- In frame of the US-Japan HEP activities, try to find mutual interests between KEK and Fermilab on advanced accelerator R&D for e.g. ATF <-> Project X / SRF / ILCTA-NML
- Some ideas include
 - *Near-term:* Continue with BPM R&D.
 - *Mid-term:* Non-invasive beam profile measurements based on optical diffraction radiation (ODR) in the near field regime.
OTR point spread function investigation.
 - *Long-term:* Development of high power laser systems.



- **ATF Damping Ring BPMs**
 - **Beam Based Alignment, including pickup tilt analysis**
 - with help of M. Woodley
 - **Systematic TbT studies, e.g. coupling minimization**
 - **Establish / help control room tools & GUIs**
 - TbT FFT display, beam orbit / manipulation display, use of the CAL system, resonant extraction, etc.
- **Upgrade of injector and transport-line BPMs?**
 - **Buttons, striplines. How many?**

- ODR offers the potential for nonintercepting, relative beam-size monitoring with near-field imaging. This is an alternate paradigm to previous far-field work at KEK and INFN. This has been proposed for the 1 GeV NML at FNAL.
- Propose tests on ATF beams with new scientific CMOS camera by PCO/Andor with very low noise to detect ODR.
- Evaluate sensitivities at 10-50 μm sigma. Test ODR PSF.

APS test at 7 GeV, 3.3 nC
Done with CCD camera,
but larger beam size case.



A.H. Lumpkin et al., Phys. Rev. ST-AB, Feb. 2007

- We convolved the electron beam's Gaussian distribution of sizes σ_x and σ_y with the field expected from a single electron at point P in the metal plane (J.D. Jackson)

$$\frac{dI}{d\omega}(u, \omega) = \frac{1}{\pi^2} \frac{q^2}{c} \left(\frac{c}{v} \right)^2 \alpha^2 N \frac{1}{\sqrt{2\pi\sigma_x^2}} \frac{1}{\sqrt{2\pi\sigma_y^2}} \times$$

$$\iint dx dy K_1^2(\alpha b) e^{-\frac{x^2}{2\sigma_x^2}} e^{-\frac{y^2}{2\sigma_y^2}},$$

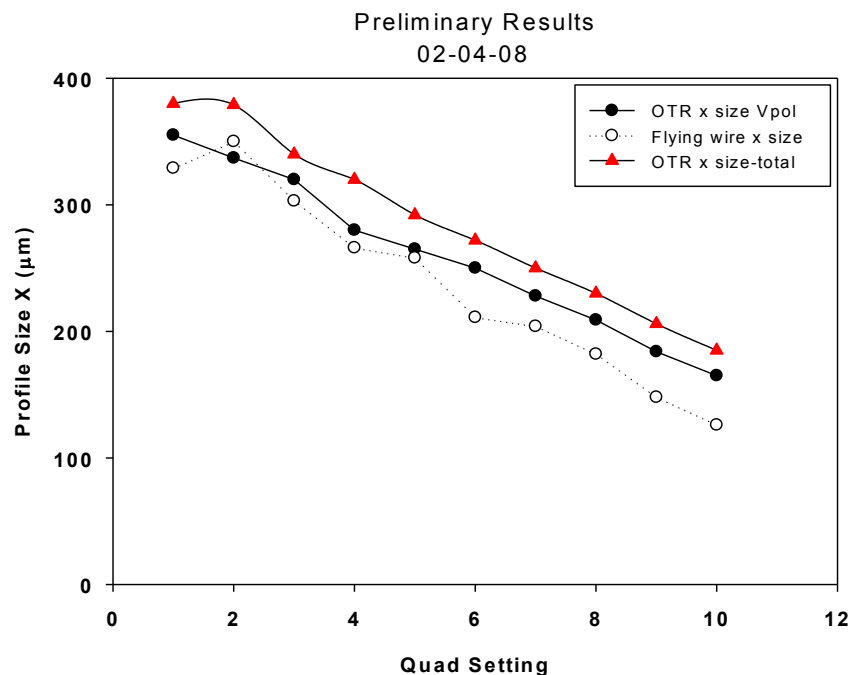
where ω = radiation frequency, v = electron velocity $\approx c$ = speed of light,
 q = electron charge, N is the particle number, $K_1(\alpha b)$ is a modified
 Bessel function with $\alpha = 2\pi/\gamma\lambda$ and b is the impact parameter.

A.H. Lumpkin et al., PRST-AB, Feb. 2007

- Mutual interest in the optical transition radiation (OTR) point spread function (PSF) and investigation of anomalous polarization effects reported in JLAB and FNAL experiments.
- Determine actual beam image size after deconvolving PSF. Perform test with beam size from 100 to 1 μm with various optical angular collection apertures.
- Subsequently apply technique to the ILC-TA beams at NML at 800 MeV.

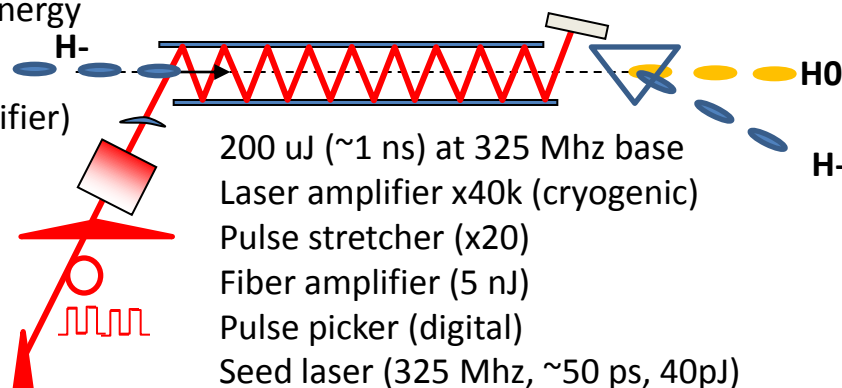
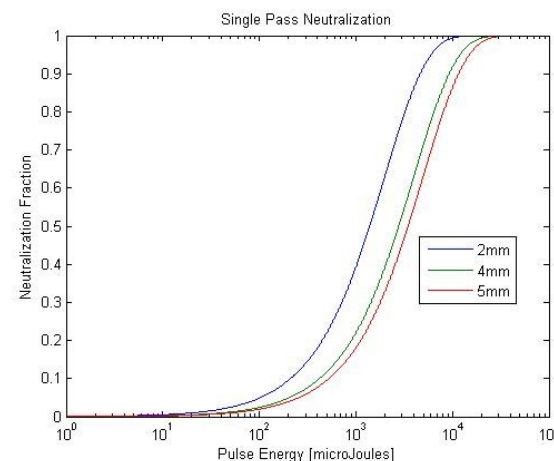
JLAB test at 4.5 GeV: Pol. OTR image is $\sim 20 \mu\text{m}$ smaller than total OTR image. This is $\sim 5\times$ more than expected from OTR PSF model.

What happens below 100 μm ?



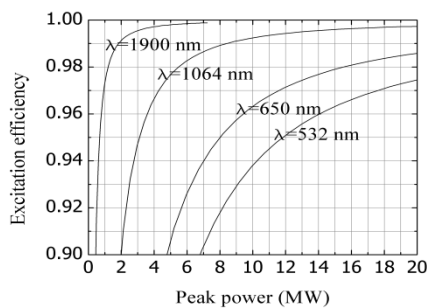
Laser Chopping

- Develop a broad band laser chopper system for 2.5 MeV H- bunches in a 325 Mhz bunch structure capable of removing arbitrary bunches to better than the 99% level.
- Depending on vertical H- beam dimensions requires tens of mJ 1 micron laser pulses at a 325 Mhz base frequency, arbitrary repetition, for laser systems with 10's MW avg. power.
- Multi-pass meander (zig-zag) cavity to reduce pulse energy requirement to approx 200μJ pulses and a pulse length on the order of 1 ns at 325 Mhz (65kW avg power)
- Components for development:
 - Appropriate insertion in MEBT (~ 1 m) -> lattice design issue
 - Seed laser running at N*325 Mhz highest pulse energy
 - Digital E0 pulse picker with good rejection (40dB)
 - Fiber amplifier (and maybe a solid state pre amplifier)
 - Pulse stretcher
 - Cryogenic Laser amplifier with gain > 104
 - Zig-zag cavity design (in vacuum)
 - Cavity length 12-24 inches
 - Material and coating selection



Laser Stripping

- Stripping of 8 GeV H⁻ requires laser wavelength of 1 to 2 microns and excitation of the n=2 atomic level. This electron in this level is removed by Lorentz stripping in downstream magnetic field.
- Laser parameters for expected H⁻ beam conditions developed for wavelengths, laser geomerty, and magnetic field at the excitation point by T. Gorlov, SNS.



Required peak laser power for excitation of the n=2 level of hydrogen for different laser wavelengths

Hardware

- High average power laser systems (seed lasers/amplifiers)
- Build up cavity to operate in vacuum and high radiation environment for 1 or 2 μm wavelengths with 10^3 build-up.
 - Material life time
 - Damage studies

| CASE | I | II | III | IV | V |
|--|--------------|--------------|-------------|-------------|-------------|
| Wavelength [nm] | 1900 | 1900 | 1064 | 1064 | 1064 |
| Incidence angle, deg | 49.77 | 49.77 | 94.63 | 94.63 | 94.63 |
| Peak power, P₀ [MW] | 1.1 | 2.1 | 6 | 6.3 | 9.7 |
| Micropulse energy [mJ] | 0.08 | 0.143 | 0.4 | 0.4 | 0.63 |
| Power for 325 Mhz [MW] | 0.026 | 0.046 | 0.13 | 0.13 | 0.21 |
| Micropulse duration, σ_t rms [ps] | 27 | | | | |
| x - rms size, $r_x = r_y$ [mm] | 2.1 | 2.0 | 8.0 | 2.0 | 2.0 |
| y - rms size, $r_x = r_y$ [mm] | 2.1 | 2.0 | 1.8 | 2.0 | 2.0 |
| x-divergence, $\alpha_x = \alpha_y$ [mrad] | 1.7 | 0 | 0.5 | 0.7 | 0 |
| y-divergence, $\alpha_x = \alpha_y$ [mrad] | 1.7 | 0 | 2.1 | 0.7 | 0 |
| Magnetic Field [T] | 0 | 1.1 | 0 | 0 | 1.1 |

- Case I Ho:YAG, circular laser, no magnetic field
- Case II: Ho:YAG, circular laser, in magnetic field
- Case III: Nd:YAG, elliptical laser, no mag. field
- Case IV: Nd:YAG, circular laser, no mag. field
- Case V: Nd:YAG, circular laser, in mag. field

Other Possible High-Power Laser Projects

Fermilab is in the preliminary stages of investigating other high-power laser projects such as:

1. Laser Proton Acceleration

- For radiation therapy for cancer treatment
- The University of Chicago and Fermilab will collaborate to set up a laser proton accelerator laboratory at Fermilab
- The laser beam must have high peak power (tens of TW).
 - ~ 1 J with a pulse length of ~ 50 fs
 - Thin foil (aluminum or carbon), gas jet or plasma targets

2. Laser Undulator for FEL

- The effect of the laser on the electron can be treated very similarly to an undulator
- Use table top laser power – 10^{18} - 10^{19} W/cm² at NML